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Rih Data Sheet

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Yoji Suzuki, Tokyo, JAPAN; Hidenobu Abe, Tokyo, JAPAN;								
** CONTINUING DATA **********************************								
** FOREIGN APPLICATIONS ************************************								
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ADDRESS 26418 REED SMITH, LLP ATTN: PATENT RECORDS DEPARTMENT 599 LEXINGTON AVENUE, 29TH FLOOR NEW YORK, NY 10022-7650								
TITLE Method of manufacturing silicon single crystal and silicon single crystal manufactured by the method								
FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:  RECEIVED  All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. time)								